

IFW

00862.023157

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

HIROSHI WATANABE ET AL.

Application No.: 10/619,576

Filed: July 16, 2003

For: SUBSTRATE PROCESSING
METHOD AND SUBSTRATE
PROCESSING APPARATUS

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) Examiner: B. Carrillo

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) Group Art Unit: 1746

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) January 25, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

FOURTH INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed Form PTO-1449. A copy of the listed document is enclosed.

This Information Disclosure Statement is to submit a document cited in the December 26, 2005 Office Action in the corresponding Taiwanese application. Copies of the Action and its English language translation are also enclosed.

The concise explanation of relevance for the non-English document may be found, inter alia, in the enclosed English language translation thereof and/or in the Taiwanese Office Action.


CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

It is believed that no fee is due in connection with this Information Disclosure Statement. However, if such a fee is deemed necessary, the Commissioner is authorized to charge it to Deposit Account 06-1205.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,


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